PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the Application of

Attn: OIPE

Shigehiro NISHINO et al.

Group Art Unit: 1722

Application No.:

10/520,141

Docket No.:

122261

Filed: September 1, 2005

For:

LARGE-DIAMETER SIC WAFER AND MANUFACTURING METHOD THEREOF

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the corrected filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

Registration No. 27,075

Mario A. Costantino Registration No. 33,565

JAO:MAC/lah

Date: December 5, 2006

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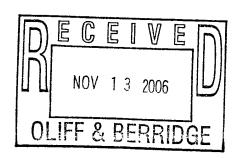




UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Dox 1450 Alexandria, Virginia 22313-1450 www.unpto.gov

APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/520,141	09/01/2005	1722	1030	122261	3	5	2

25944 **OLIFF & BERRIDGE, PLC** P.O. BOX 19928 ALEXANDRIA, VA 22320



CONFIRMATION NO. 9522 CORRECTED FILING RECEIPT *OC000000021162745*

Date Mailed: 11/08/2006

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Applicant(s)

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Assignment For Published Patent Application

MITSUI ENGINEERING & SHIPBUILDING CO., LTB. TOKYO, JAPAN

LTD -)

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/08312 06/30/2003

Foreign Applications

JAPAN 2002-202953 07/11/2002

If Required, Foreign Filing License Granted: 09/12/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/520,141**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No

Title

Large-Diameter SiC Wafer and Manufacturing Method Thereof

Preliminary Class

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